IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: Deshmukh, et al. Case: 8233/ETCH/SILICON/JB

Serial No.: 10/674,631 Filed: September 29, 2003

Examiner: Umez Eronini, Lynette T Group Art Unit: 1765

Confirmation No.: 4703

Title: Method and Apparatus for Endpoint Detection During An Etch Process

Mail Stop Amendment

COMMISSIONER FOR PATENTS

P.O. Box 1450

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SIR:

RESPONSE TO FINAL OFFICE ACTION DATED JULY 6, 2006

In response to the Final Office Action dated July 6, 2006, having a shortened statutory period for response set to expire on October 6, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although the Applicants believe that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 50-3562 for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.